

Form PTO 1449
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LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

KAORI UMEZAWA

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GROUP

1584 U.S. P.
09/358388
07/01/99

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	5,013,680	05/07/91	Tyler A. Lowrey, et al.			
	AB	4,506,434	03/85	Ogawa, et al.			
	AC	4,571,819	02/86	Rogers, et al.			
	AD	4,593,459	06/86	Poppert, et al.			
A.M.	AE	5,763,932	06/98	Pan, et al.			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES	NO
A.M.	AO	63-76352	04/06/88	Japan (with English abstract)		x
	AP	4-273462	09/29/92	Japan (with English abstract)		x
	AQ	41-33-219	06/04/92	Germany		x
	AR	0 606 758	07/20/94	Europe	x	
	AS	0 570 321	11/18/93	Europe	x	
	AT					
	AU					
	AV					

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

A.M.	AW	C.J. BRINKER, et al. "Sol-Gel Transition in Simple Silicates", JOURNAL OF NON-CRYSTALLINE SOLIDS 82, (pgs. 117-126), North-Holland, Amsterdam, 1986.
	AX	Wolf, et al., "Silicon Processing for the VLSI Era," 1985, pp. 198-200.
	AY	Electronics & Communication in Japan, Part 2, vol. 78, no. 10, pages 65-72, October 1, 1995, Takeshi FURUSAWA, et al., "NEW REFLOWABLE ORGANIC SPIN-ON GLASS FOR ADVANCED INTERLEVEL DIELECTRIC PLANARIZATION"
	AZ	

Examiner

ANH D. MA

Date Considered

2/15/00

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.